## Kinetic Monte Carlo modelling of semiconductor growth





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#### **Time and length scales**



# Methods of Statistical Physics

#### **Discrete models in Statistical Physics**

Ising model (magnetism)

$$H(s) = -J_q \sum_i \sum_{j \in n(i)} s_i s_j - \mu_B B \sum_i s_i$$



-1

- Lattice-gas interpretation  $c_1=0,1$   $s_i=2c_i-1$ 

$$H = -4J_q \sum_i \sum_{j \in n(i)} c_i c_j + 2(qJ_q - \mu_B B) \sum_i c_i - N(qJ_q - \mu_B B)$$

Goal:
 Calculation of thermal averages

### A discrete model for epitaxy: solid-on-solid (SOS) model

- Atoms are symbolized by little cubes placed on a lattice.
- The growth surface has no voids, no "overhangs".
- Atoms move by discrete hops with rate  $\Gamma = \exp(-E/kT)$ .
- The binding energy is determined by the # of neighbors n  $E = E_D + n E_B$



#### **Stochastic sampling**

- Calculating thermal averages in many-particles systems requires evaluation of high-dimensional integrals.
- Choosing the sampling points in an (almost) random way is a good strategy, in particular in high dimensions !
- Even better: importance sampling -- density of sampling points proportional to local value of the integrand
- Idea: create a stochastic process that achieves importance sampling.

$$\pi/4 = 0.78 .. \approx 20/25 = 0.8$$



#### **Metropolis Sampling**

• Solution: Importance Sampling with

$$w(\mathbf{q}) = rac{\exp\left(-V(\mathbf{q})/(k_B T)
ight)}{Z'}$$

- Generate random support points, distributed according to  $w(\mathbf{q})$ , i.e., out of total K points,  $k_i = Kw(\mathbf{q})$  in the unit volume around  $\mathbf{q}_i$
- The expectation value of an observable is calculated as  $\langle A \rangle \approx \frac{1}{K} \sum_{i=1}^{K} k_i A(\mathbf{q}_i)$
- The Metropolis algorithm generates, starting from  $q_0$ , successively a sequence of K configurations  $q_i$ , distributed according to w(q).
- Even so we don't know Z', this is possible, because it is just the correct **relative** probabilities that matter:

– accept new config. 
$$\mathbf{q}_{i+1}$$
 , if  $\exp\left(-rac{V(\mathbf{q}_{i+1})-V(\mathbf{q}_i)}{k_BT}
ight)> ext{rnd}$ 

 $rnd \in [0,1[$ 

• This assures that 
$$\frac{w(\mathbf{q}_{i+1})}{w(\mathbf{q}_i)} = \exp\left(-\frac{V(\mathbf{q}_{i+1}) - V(\mathbf{q}_i)}{k_B T}\right)$$



From MC to kMC: the *N*-fold way

# Classification of spins according to their neighborhood



#### 25521255212545362262126225521

class	central spin	neighbors	class members $n_i$
1	↑	↑,↑	4
2	↑	↑,↓	12
3	↑	$\downarrow,\downarrow$	1
4	Ļ	$\downarrow,\downarrow$	1
5	↓	<b>↑</b> ,↓	8
6	↓	<b>↑,</b> ↑	3

#### The *N*-fold way algorithm in MC

- processes are chosen with a probability proportional to their rates
- no discarded attempts (in contrast to Metropolis)

pointer steered by random number

class	central	neighbors	class
	spin		members $n_i$
1	1	↑,↑	4
2	↑	↑,↓	12
3	1	$\downarrow,\downarrow$	1
4	↓ ↓	$\downarrow,\downarrow$	1
5	↓ ↓	<b>↑</b> ,↓	8
6	↓ ↓	<b>↑</b> ,↑	3

# Simulations of non-equilibrium processes: kinetic MC

- While being aware of all processes possible at an instant of time, we need a way of (randomly) selecting one process with the appropriate relative probability.
- An internal clock keeps track of the advancement of physical time.
  - If the processes are clearly separated in time, i.e. processes are uncorrelated on the time scale *during which* the processes takes place, the waiting time for each individual process has Poissonian distribution. (K. A. Fichthorn and W.H. Weinberg, J. Chem. Phys. 95, 1090 (1991))
- We need to update the list of all possible processes according to the new situation after the move.

#### Specific algorithms:

- process-type list algorithm
- binary-tree algorithm
- time-ordered-list algorithm

#### **Application to a lattice-gas model**

- example: lattice L<sub>x</sub> x L<sub>y</sub>
- tool's algorithm: first select one particle, then select one move of that particle
- the correct solution: cumulated partial rates  $r_k = \sum_{i=1}^k \Gamma_i$ , normalized to the total rate  $R = r_N$
- selection process: draw a random number  $\rho$  and compare it to all the  $r_k/R$  sequentially; as soon as  $\rho$  exceeds  $r_k/R$ , execute process k
- problem: we need to compare  $\rho$  to many (in the worst case all) of the  $r_k/R$
- note: Selecting a process with the right probability requires that we can enumerate all *N* processes.





for p process types, we need to compare only to the p numbers  $N^{(k)} \Gamma^{(k)}$ , k=1,p, rather then to **all**  $r_k/R$  (which are much more numerous)

### flow chart for a kMC algorithm



From molecular dynamics to kinetic Monte Carlo

#### From molecular dynamics to kinetic Monte Carlo



### **Transition State Theory (1-dim)**

• Kramer's rate theory

$$\Gamma = \frac{\lambda}{\omega_b} \left( \frac{\omega_0}{2\pi} \exp\left(-\frac{E_b}{kT}\right) \right) \qquad \lambda = \left(\frac{\gamma^2}{4} + \omega_b^2\right)^{1/2} - \frac{\gamma}{2}$$

 $\gamma$ : friction due to coupling to the heat bath

• high-friction limit

$$\Gamma = \frac{\omega_0 \omega_b}{2\pi\gamma} \exp\left(-\frac{E_b}{kT}\right)$$

• 'medium' friction → transition state theory

$$\Gamma = \frac{\omega_0}{2\pi} \exp\left(-\frac{E_b}{kT}\right)$$

P. Hänggi, P. Talkner & M. Borkovec, Rev. Mod. Phys. **62**, 251 (1990)

 $\omega_{c}$ 

 $\omega_{b}$ 

 $E_{\rm h}$ 

# From the PES to rate constants Γ (multi-dimensional)



 $\Gamma = kT/h Z_{TS}/Z_i =$  (harmonic & classical approximation)

 $= \prod_{N} v_{k,i} / \prod_{N-1} v_{k,TS} exp(-\Delta E/kT)$ 

#### **Temperature-accelerated dynamics (TAD)**



M.R. Sørensen and A.F. Voter, J. Chem. Phys. **112**, 9599 (2000) **1/T** 

#### **TAD: Collective processes**



F. Montalenti, M.R. Sørensen and A.F. Voter, Phys. Rev. Lett. **87**, 126101 (2001)

# **Application I:**

## **GaAs nanowire growth**



#### **Gold-catalysed nanowire growth**

- much higher growth speed in a particular crystallographic direction [GaAs(111)B] compared to extended substrate
- liquid Au droplet used to store Ga (as Au-Ga alloy), but inefficient for As species
- role of material transport along the wire side walls ?



### **Polytypism in GaAs nanowires**

 segments of zincblende (ZB, which is the ground state in bulk) and wurtzite (WZ) crystal structure, depending on growth conditions
 2 types of structurally different facets !



#### Arsenic supply to the interface

• arsenic vacancy emission into the solid  $D_{V_{As}}(T) = \Gamma_0 \exp\left(-\frac{\Delta E}{k_B T}\right)$  alognent specific XEDS analysis

10

5

0

0

20

element-specific XEDS analysis A.I. Persson et al., Nature Materials **3**, 667 (2004)

#### A.I. P Natu

or

 diffusion of As dissolved in the liquid Stokes-Einstein relation

$$D_{\mathrm{As}@\mathrm{Au}}(T) = \frac{k_B T}{6\pi r_{\mathrm{As}} \eta_{\mathrm{Au}}(T)}$$



60

40

80

100

120

#### **Arsenic vacancies**

- unstable as neutral vacancy (a so-called "negative-U" system)
- strong contraction of the vacancy tetrahedron for negatively charged vacancy, as bonding linear combination of Ga dangling bonds becomes occupied



### **V**As diffusion in wurtzite

• in wurtzite *ab*-plane, barriers are lower as compared to zincblende case





#### **V**<sub>As</sub> diffusion in wurtzite

along the c-axis, V<sub>As</sub> needs to go a detour to avoid crossing the Ga-Ga coordination line → higher barrier than in zincblende





#### **Facet-dependent Ga diffusion**



 $\rightarrow$  type 2 wurtzite wires support faster diffusion on the side wall.

#### As diffusion is much slower !



**impingement** on the Au particle, rather than via diffusion on the side facets.

#### Side wall nucleation and radial growth

- type-II wires: immobile surface GaAs species leads to nucleation
- type-I wires: critical nucleus of more than one Ga atom (+ some As), critical adatom density nc



Tapering of the wires after sidewall nucleation if *L* exceeds the collection length

V. Pankoke, S. Sakong and P. Kratzer, PRB **86**, 085425 (2012)

## **Application II:**

# Molecular beam epitaxy on GaAs(001) β2(2x4)



#### **Rates from first-principles calculations**





#### Surface diffusion on GaAs(001): mapping of PES to network graph

PES from DFT calculations  $\rightarrow$  network of hops



#### kMC with explicit list of process types

#### Voter's lattice kMC:



A.F. Voter PRB 34, 6819 (1986)

- simulation on a lattice •
- group possible transitions  $\Gamma(f,i)$ • from i to f into classes, each class is characterized by a rate
- classification of initial and final state by 'atomic neighborhoods' e.g., the number and relative position of neighbors define a process type

#### DFT-based kMC:





possible hops .. modified rates in the trench... due to neighbors.



### kinetic Monte Carlo simulations for GaAs epitaxy

- 32 microscopically different Ga diffusion processes, and As<sub>2</sub> adsorption/desorption are included explicitly
- computational challenge: widely different time scales (10<sup>-12</sup> sec to 10 sec)
- simulation cell
   160 x 320 sites
   (64 nm x 128 nm)



#### kinetics of island nucleation and growth

Ga

side view As top 0 view

1/60 of the full simulation cell  $As_2$  pressure = 0.85 x 10<sup>-8</sup> bar Ga deposition rate = 0.1 ML/s T = 700 K



#### island density



#### scaling with temperature ?



### Summary: Bridging the time-scale gap

- molecular dynamics (Car-Parrinello method)
- accelerated molecular dynamics
  - using a boost potential (Voter, Fichthorn,...)
  - temperature-accelerated MD (Montalenti et al. PRL 87, 126101 (2001))
- kinetic Monte Carlo with transition state search on the fly (avoids both lattice approximation and predefined rate table)
- lattice kinetic Monte Carlo, N -fold way (Voter PRB 34, 6819 (1986))

computational effort



risk of oversimplification



"Keep things as simple as possible, but not simpler .."

Thank you for your attention ! Summary: arXiv:0904.2556